

Notice of References Cited	Application/Control No. 10/767,518		Applicant(s)/Patent Under Reexamination ABE ET AL.	
	Examiner Shahid Al Alam		Art Unit 2162	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,694,609	12-1997	Murata, Makoto	715/513
*	B	US-6,061,697	05-2000	Nakao, Yoshio	715/513
*	C	US-6,424,980	07-2002	Iizuka et al.	715/513
*	D	US-6,564,256	05-2003	Tanaka, Nobuyuki	709/219
*	E	US-7,039,625	05-2006	Kim et al.	707/1
*	F	US-7,092,938	08-2006	Brown et al.	707/4
*	G	US-7,099,861	08-2006	Youn, Seok Ho	707/3
*	H	US-2001/0014900	08-2001	Brauer et al.	707/513
*	I	US-2003/0093760	05-2003	Suzuki et al.	715/523
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Ohtsuki, Mika et al., "Structured Document Framework for Design Patterns Based on SGML", Proceedings of the 21st Annual International Conference on Computer Software and Application, 13-15 August 1997, Pages 320-323.
	V	Souad, Tayeb-Bey et al., "Analysis and Conversion of Documents", Proceedings of the 14th International Conference on Pattern Recognition, Vol. 2, 16-20 August 1998, Pages 1089-1091.
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.